5AU-2823



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re PATENT application of:	)
Shunpei YAMAZAKI et al.	) Art Unit: 2823
Serial No. 09/352,194	) Examiner: F. Toledo

Filed: July 13, 1999

For: CRYSTALLINE SEMICONDUCTOR THIN

FILM, METHOD OF FABRICATING THE )

SAME, SEMICONDUCTOR DEVICE, AND )

METHOD OF FABRICATING THE SAME

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: The Commissioner for Patents, Washington, D.C. 20231, on April 4, 2001.

**INFORMATION DISCLOSURE STATEMENT** 

Honorable Commissioner for Patents

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application.

A copy of the reference is submitted herewith in accordance with 37 C.F.R. 1.98(a). The requisite fee of \$180 is also submitted herewith in accordance with 37 C.F.R. 1.97(c).

The Examiner is further requested to consider the References cited on the Information Disclosure Statements filed September 1, 2000; November 30, 2000 and January 29, 2001.

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The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

Eric J. Robinson Reg. No. 38,285

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